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Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 109067		APPLICATION NO. New U.S. Patent Application	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANTS Shouji YAJIMA, Hiroyuki HIRAJIWA, Yasuji ISHIDA			
				FILING DATE March 28, 2001			

  

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
CL		5,707,908	01/13/1998	KOMINE et al.	—	—

  

FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
CL		WO 00/41226 A1 (abstract only)	07/13/2000	WIPO	✓	—
1		WO 00/58761 A1 (abstract only)	10/05/2000	WIPO	—	—
		WO 01/02311 A1 (abstract only)	01/11/2001	WIPO	—	—
		JP 62-235223 A (w/abstract)	10/15/1987	Japan	—	—
		JP 6-166527 A (w/abstract)	06/14/1994	Japan	—	—
		JP 7-113902 A (w/abstract)	05/02/1995	Japan	—	—
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		JP 8-107060 A (w/abstract)	04/23/1996	Japan	—	—
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✓		JP 10-279322 A (w/abstract)	10/20/1998	Japan	✓	✓
CL		JP 11-209134 A (w/abstract)	08/03/1999	Japan	—	—

  

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)	

  

EXAMINER  <div style="text-align: center;"> </div>	DATE CONSIDERED <div style="text-align: center;"> </div>
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